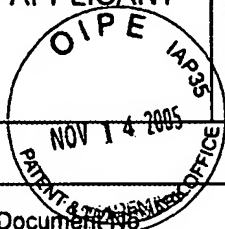


**INFORMATION
DISCLOSURE
STATEMENT BY APPLICANT**

Sheet 1 of 1



Application Number: 10/646,460
Filing Date: August 22, 2003
First Named Inventor: Kenneth COLLINS, et al.
Group Art Unit: 1763
Examiner Name: Maureen G. Arancibia
Attorney Docket Number: 006915 P09

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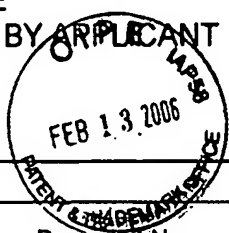
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Examiner's Signature: Maureen G. Arancibia

Date Considered: 03/30/2006

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT Sheet 1 of 1	Application Number: 10/646,460 Filing Date: 08/22/2003 First Named Inventor: Kenneth COLLINS, et al. Group Art Unit: 1763 Examiner Name: Maureen G. Arancibia Attorney Docket Number: 006915/P09
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Examiner's Signature: <i>Maureen G. Arancibia</i>	Date Considered: 03/30/2006
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